



Serial No. 10/673,581  
SEC.745C  
Amendment dated 22 February 2005

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent application of :  
Ji-Soo KIM et al. : Group Art Unit 2881  
Serial No. 10/673,581 : Examiner Kalimah FERNANDEZ  
Filed 30 September 2003 :

METHOD OF DETERMINING WHETHER  
A CONDUCTIVE LAYER OF A  
SEMICONDUCTOR DEVICE IS EXPOSED  
THROUGH A CONTACT HOLE

**AMENDMENT UNDER 37 C.F.R. § 1.112**

U.S. Patent and Trademark Office  
Customer Window, **Mail Stop Amendment**  
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401 Dulany Street  
Alexandria, VA 22314

Sir:

In response to the Office Action of 19 October 2004, the period for response to which is hereby being extended by the accompanying Petition and Petition Fee through 19 February 2005, reexamination and reconsideration of the above-referenced U.S. patent application are respectfully requested in view of the following Remarks.

**Remarks** begin on page 2 of this paper.